

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Norikazu SUGAYA et al.

Serial No. 10/590,503

Filed August 24, 2006



Attorney Docket No. 2006_1372A

Confirmation No. 1096

Group Art Unit 1792

Examiner William P. Fletcher

Mail Stop: AMENDMENT

METHOD OF PREVENTING ELUTION OF
NICKEL FROM WETTED INSTRUMENT
OF COPPER ALLOY, PROTECTIVE FILM
FORMATION AGENT FOR PREVENTING
ELUTION OF NICKEL AND DETERGENT
FOR PREVENTING ELUTION OF NICKEL

RESPONSE

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated March 4, 2010, please amend the present application as follows: